



## Carbon Based Electronic Devices

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### Message from the Guest Editors

For more than 50 years, silicon has dominated the electronics industry. However, this growth will come to an end, due to resources limitations. Thus, research developments need to focus to alternative materials, with higher performance and better functionality. Current research achievements have indicated that carbon is one of the promising candidates for its exploitation in the electronics industry. Whereas the physical properties of graphite and diamond have been investigated for many years, the potential for electronic applications of other allotropes of carbon (fullerenes, carbon nanotubes, carbon nanofibres, carbon films, carbon balls and beads, carbon fibers, etc), has only been appreciated relatively recently. Carbon-based materials offer a number of exciting possibilities for new applications of electronic devices, due to their unique thermal and electrical properties. However, the success of carbon-based electronics depends on the rapid progress of the fabrication, doping and manipulation techniques.





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